



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Thomas A. Figura, Kevin Donohoe, & Thomas Dunbar

Serial No.: 09/470,650

Filed: December 22, 1999

Title: USE OF A PLASMA SOURCE TO FORM A LAYER
DURING THE FORMATION OF A SEMICONDUCTOR DEVICE

§
§ Group Art Unit: 2813
§
§ Examiner: Lisa Kilday
§
§ Atty. Docket: 94-028004
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#10/Response
1-22-02
Harrison

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RESPONSE TO THE OFFICE ACTION DATED AUGUST 6, 2001

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:	
Assistant Commissioner for Patents Washington, DC 20231 on	
Date <u>11/8/01</u>	Signature <u>Susan Ferone</u>

Applicants herein respond to the Office Action dated August 6, 2001.

REMARKS

Claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43 are pending.

Claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43 are rejected.

Applicants request reconsideration of claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43.

I. Rejection of claims under §112

The Examiner rejected claims 36-43 under §112 ¶2, arguing that the use of the term "environment" renders the claims indefinite. First, Applicants point out that, of the rejected claims, the term "environment" is neither expressed nor incorporated in claims